FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT					ATTY. DOCKET 033082 M 334 APPLICANT: Kenji SUZ FILING DATE July 12, 2006		SERIAL NO. 10/585,828 CUKI, et al. GROUP ART UNIT To Be Assigned		
*Examiner's Initials		DOCUMENT NUMBER	DATE		NAME	CLASS	SUB- CLASS	FILING D IF APPROF	
	AA	6,130,145	October 10, 2000	llg et a	ıl.				
	AB	5,913,145	June 15, 1999	Lu et a	<u> </u>				
	AC	5,654,237	August 5, 1997	Suguro	et al.				
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	AH	11-265992	9/28/1999		JAPAN			abstract	
	Al	11-135455	5/21/1999		JAPAN		-	abstract	
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	AM			17			[]		
	AN								
		THER INFORM	I IATION (Including Au	L uthor, T	itle, Date, Pertine	LI ent Pages, f	l Etc.)		
	AO	PCT Notification of Transmittal of Copies of Translation of the International Preliminary Examination Report (Form PCT/IB/338) dated January 2004							
	AP	PCT International Preliminary Report on Patentability (Form PCT/IPEA/409) dated January 2004							
	AQ	Chinese Office Action issued on April 4, 2008 with English language translation							
	AR	Korean Office Action issued on May 29, 2007							
	AS	Korean non-pa	itent document No. 20)01-38S	D-7-8. Roh et al.	"Characte	ristics of	Metal-oxide	
		Semiconductor	r (MOS) Devices with.	Meta	l", pages 513-519	9 (2001)	1101100 0.	Wotar Oxido	,
EXAMINER:				DAT	TE CONSIDERED:				
*EXAMINER:	Initial if	reference considered	ered, whether or not citat	tion is in	conformance with	MPEP 609; I	Draw line	through citati	ion if